

Diamond Detector Technology: Status and Perspectives

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on behalf of the RD42 Collaboration

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Section 1

Motivation

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- innermost layers → highest radiation damage ($100 \text{ MHz}/\text{cm}^2$ to $200 \text{ MHz}/\text{cm}^2$)
 - current detector is designed to survive ~ 12 month in High-Luminosity LHC
 - → **R&D for more radiation hard detector designs and/or materials**

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 - → **R&D for more radiation hard detector designs and/or materials**

Diamond as Detector Material:

- properties
 - ▶ radiation tolerance
 - ▶ isolating material
 - ▶ high charge carrier mobility
 - ▶ smaller signal than in silicon

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Diamond as Detector Material:

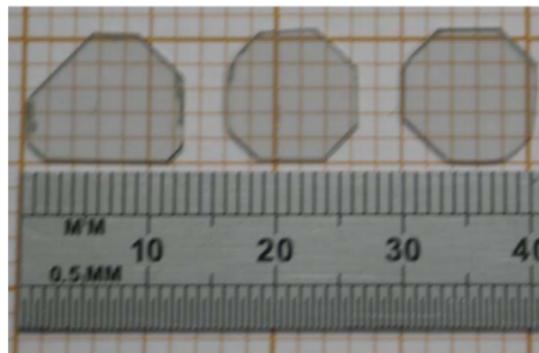
- properties
 - ▶ radiation tolerance
 - ▶ isolating material
 - ▶ high charge carrier mobility
 - ▶ smaller signal than in silicon
 - investigation of the signal independence/dependence on incident particle flux in various detector designs:
 - ▶ pad → full diamond as single cell readout
 - ▶ pixel → diamond sensor on pixel chips
 - ▶ 3D → strip/pixel detector with clever design to reduce drift distance

Section 2

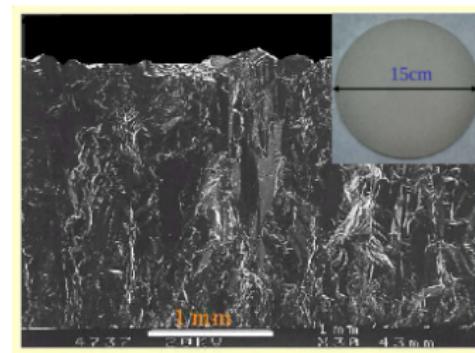
Diamond Types

Diamond Types

- diamonds artificially grown with chemical vapour deposition (CVD)
- investigation of two different diamond types:



(a) single-crystalline CVD



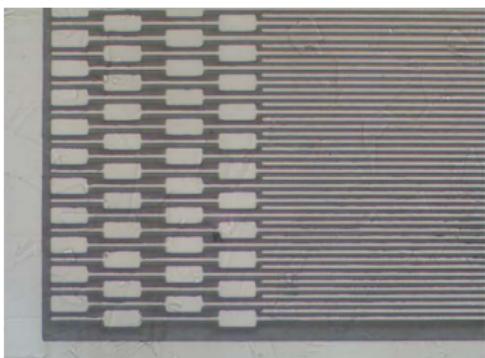
(b) poly-crystalline CVD (courtesy of E6)

- only small sizes ($\sim 0.25 \text{ cm}^2$)
- pCVD signals smaller than scCVD (1:2) in planar configuration
- large wafers (5" to 6" \varnothing)

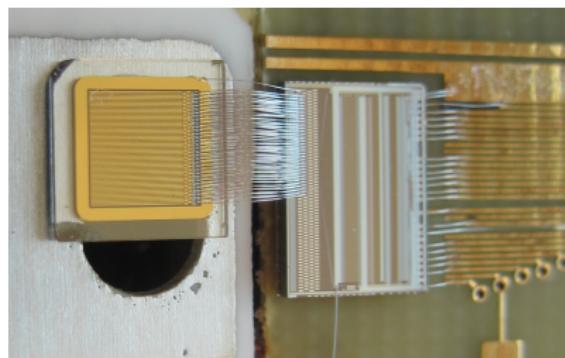
Section 3

Radiation Tolerance

Devices



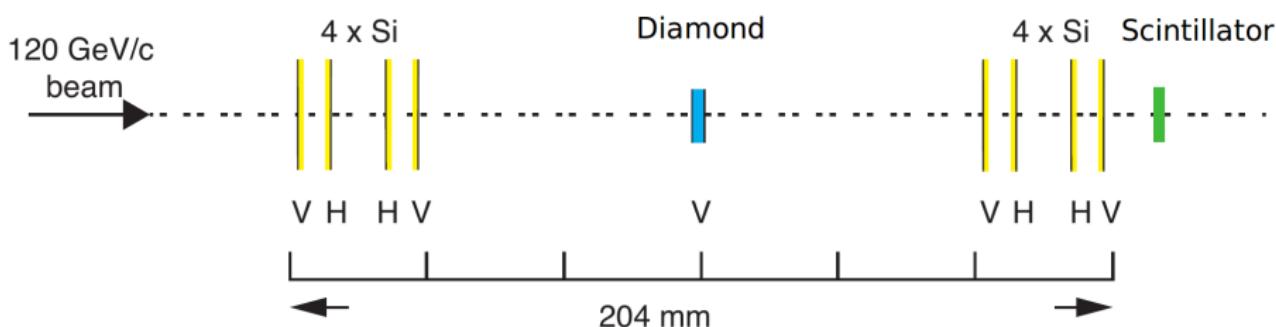
(a) strip metalisation pattern



(b) mounted diamond with amplifier

- patterning the diamonds → create pad, strip and pixel devices
 - metalisation on both sides → almost edgeless
 - segmentation critical for radiation studies → charge & position

Schematic Beam Test Setup



- characterisation of irradiated devices in beam tests
 - transparent or unbiased hit predictions from telescope

Irradiation at CERN PS with 24 GeV protons

damage equation:

$$n = n_0 + k\phi$$

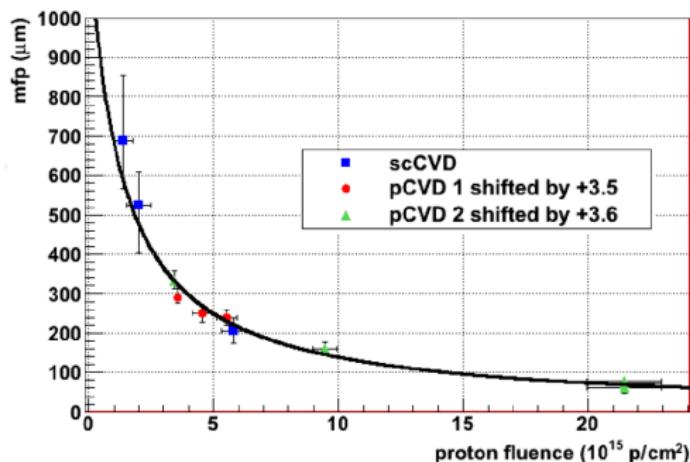
$$\frac{1}{mfp} = \frac{1}{mfp_0} + k\phi$$

n_0 – initial number of traps

mfp_0 – initial mean free path

k – damage constant

ϕ – fluence



- assume same mean free path for electrons and holes
- results up to $2.2 \times 10^{16} p/cm^2$ (~ 500 Mrad)
- same damage curves and constant (k) for scCVD and pCVD diamonds
- larger mfp_0 performs better at any fluence

Charge Collection Distance (ccd) vs. Mean Free Path (mfp)

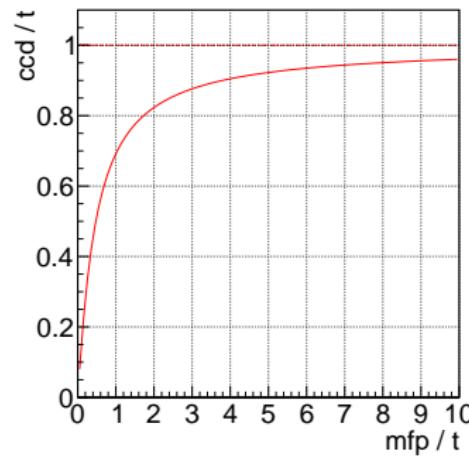
- ccd = average distance between electron and hole until trapped
 - for scCVD: $ccd \sim \text{thickness}$, for pCVD: $ccd < \text{thickness}$
 - ccd direct measurement (no correction)
 - mfp correct theory → correct data with assumptions (i. a. $mfp_e = mfp_h$)

equation for ccd:

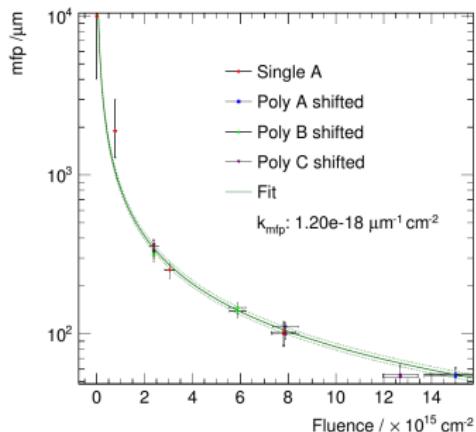
$$\frac{ccd}{t} = \sum_i \frac{mfp_i}{t} \left(1 - \frac{mfp_i}{t} \left(1 - e^{-\frac{t}{mfp_i}} \right) \right)$$

t – thickness

i – electrons & holes



Summary of Proton, Neutron and Pion Irradiation



(a) irradiation at LANL with 800 MeV protons (up to 1.4×10^{16} p/cm²)

| Particle | Energy | Relative k |
|-----------------|---------------|-------------------|
| Proton | 24 GeV | 1.0 |
| | 800 MeV | 1.79 ± 0.13 |
| | 70 MeV | 2.4 ± 0.4 |
| | 25 MeV | 4.5 ± 0.6 |
| Neutron | 1 MeV | 4.5 ± 0.5 |
| Pion | 200 MeV | $2.5 - 3$ |

(b) summary

Section 4

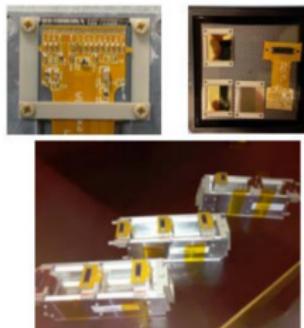
Diamond Devices in Experiments

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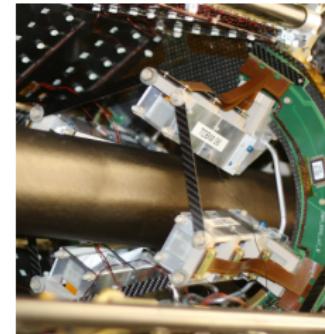
- beam condition/loss monitors
 - ▶ essential in all modern collider experiments
- current generation pixel detectors
 - ▶ **ATLAS Diamond Beam Monitor (DBM)**
- future HL-LHC trackers
 - ▶ **3D diamond detectors**
- future beam condition/luminosity monitor
 - ▶ multipad design BCM'

ATLAS DBM

- diamond pixel detectors in ATLAS (tracking)
- total production of 45 diamonds ($t = 500 \mu\text{m}$) on FE-I4b chips
- module assembly at CERN
- installed during LS1
- 8 telescopes (2 Si & 6 Diamond) symmetric around ATLAS IP
- thresholds tuned to $\sim 2500 \text{ e}$



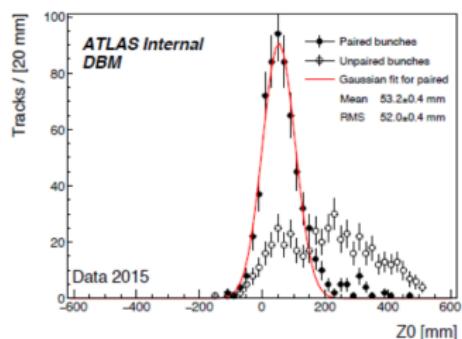
(a) cable, detectors, telescopes



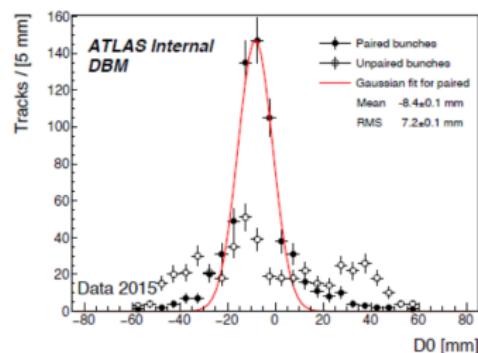
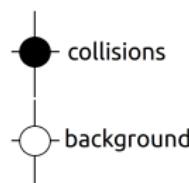
(b) 4 mounted telescopes

Tracking

- reconstruction of tracks from hits of 3 modules



(a) longitudinal distance to IP



(b) radial distance to IP

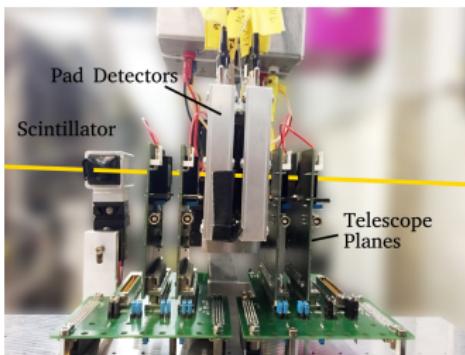
- plots with initial alignment
- clear discrimination between background and collisions
- loss of modules (Si/D)
 - successful re-commissioning of surviving modules
- diamond and Si modules now part of ATLAS data taking

Section 5

Rate Studies

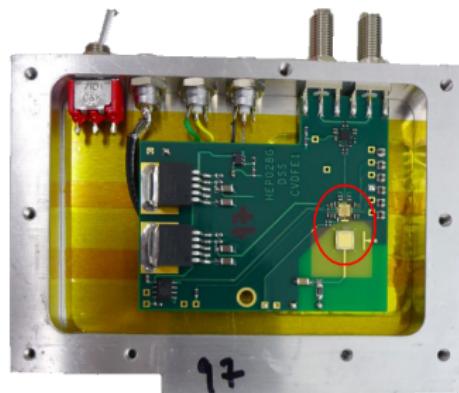
Setup

- rate studies conducted with $260 \text{ MeV}/c \pi^+$ at Paul Scherrer Institute (PSI)
- tunable particle fluxes from $\mathcal{O}(1 \text{ kHz/cm}^2)$ to $\mathcal{O}(10 \text{ MHz/cm}^2)$
- detectors tested in ETHZ beam telescope (based on CMS-Pixel-Chips)

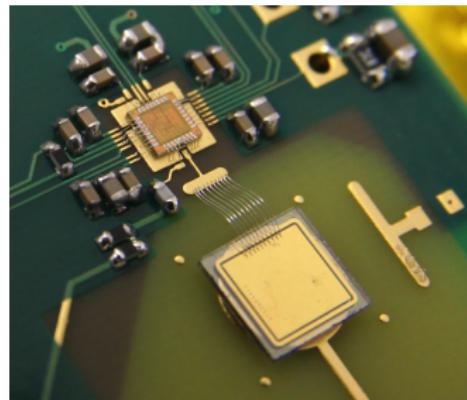


- 4 tracking planes with particle trigger
- scintillator for precise trigger timing $\rightarrow \mathcal{O}(1 \text{ ns})$

Pad Detectors



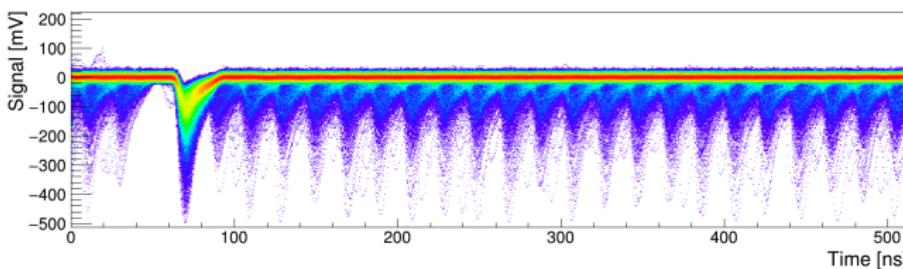
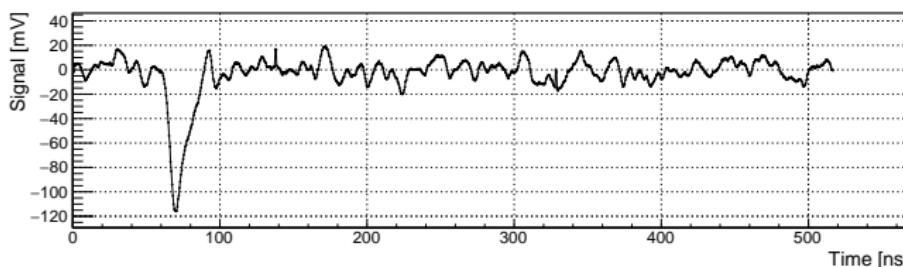
(a) fast amplifier box



(b) diamond and fast amp

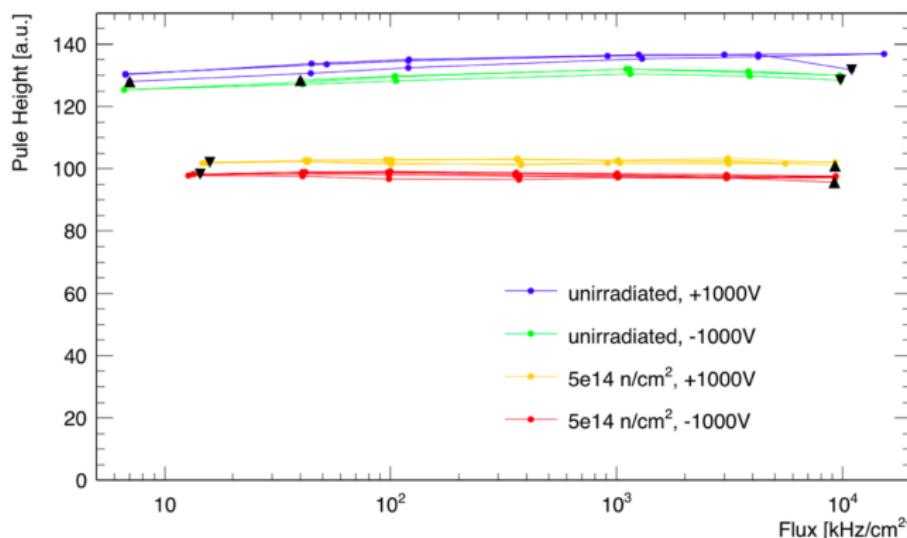
- diamonds in custom built amplifier boxes from Ohio State University (OSU)
- cleaning, photo-lithography and Cr-Au metallisation at OSU
- low noise, fast amplifier with $\mathcal{O}(5\text{ns})$ rise time
- prototype for HL-LHC BCM/BLM

Waveforms



- fast amplifier and good timing resolution → resolve bunch structure of PSI beam
- bunch spacing of 19.8 ns clearly visible

Results



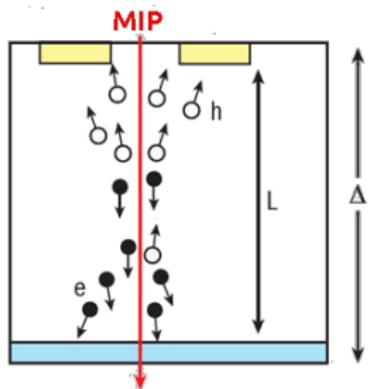
- no rate dependence observed in pCVD diamonds up to 10 MHz/cm²
- no absolute pulse height and noise calibration yet
- extending radiation doses to 1×10^{16} n/cm²

Section 6

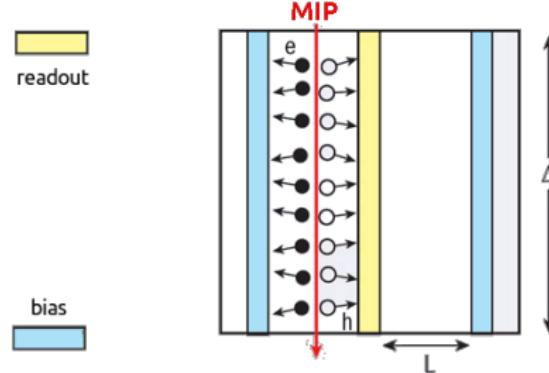
3D Detector Development

Detector Concept

- after large irradiation → all detector materials trap limited ($\text{mfp} < 75 \mu\text{m}$)
- **keep drift distances smaller than mean free path**



(a) planar detector

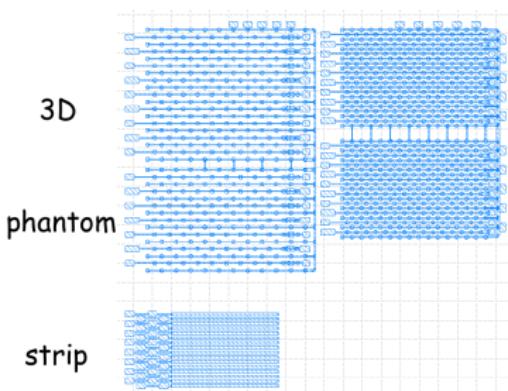


(b) 3D detector

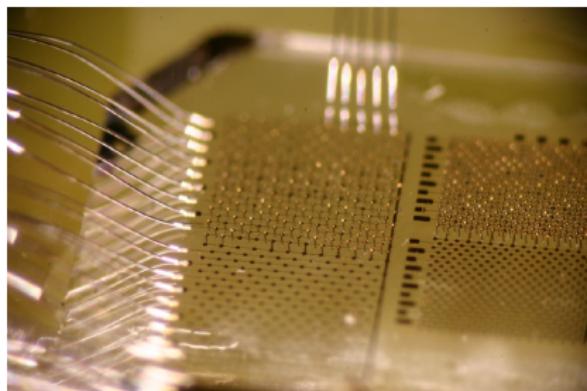
- bias and readout electrode inside detector material
- same thickness $\Delta \rightarrow$ same amount of induced charge \rightarrow shorter drift distance L
- electrode columns drilled with 800 nm femtosecond laser
- convert diamond into resistive mixture of carbon phases

3D Multi Detector (2015)

- pCVD diamond with 3D, phantom and strip detector on single sensor
- 3D column efficiency of 92 %
- 3D cell size: $150 \mu\text{m} \times 150 \mu\text{m}$
- signal read out as ganged cells



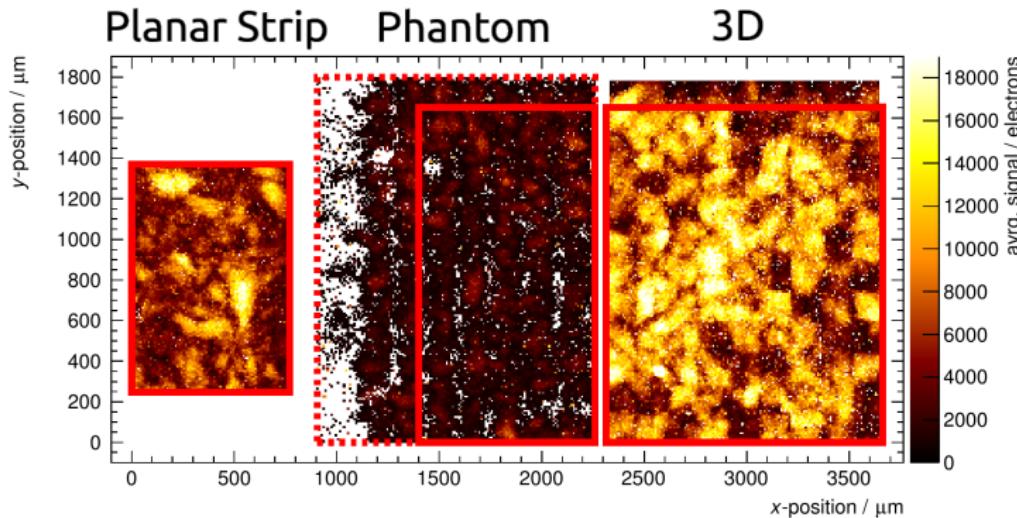
(a) metalisation pattern



(b) photograph

3D Multi - Signal Map

- square cells visible (9 broken cells)
- signals in 3D already bigger by eye
- phantom (no columns) → no pulse height

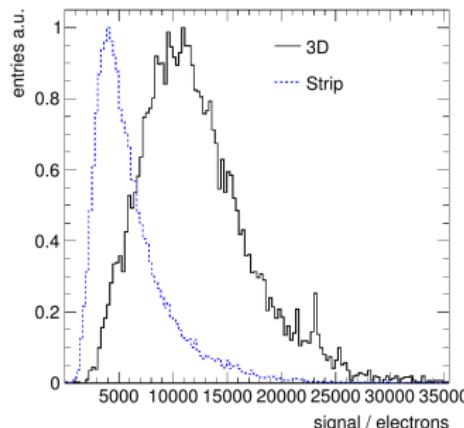


3D Multi - Result

- measured signals for diamond thickness 500 μm :

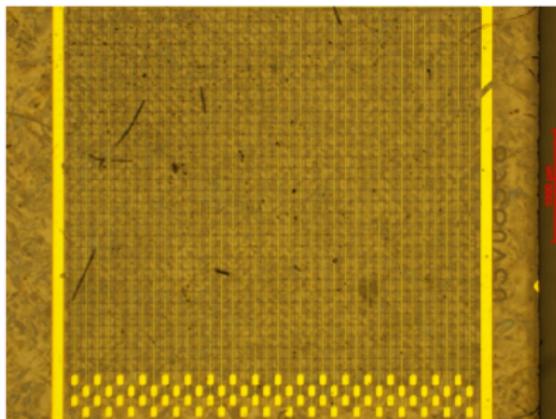
| Device | Mean Charge [e] | ccd [μm] |
|--------------|-----------------|-----------------------|
| planar strip | 6900 | 192 |
| 3D | 13500 | 350 – 375* |

- * ccd_{eq} - equivalent ccd to observe same charge in planar device
- collect > 75 % charge in pCVD for the first time

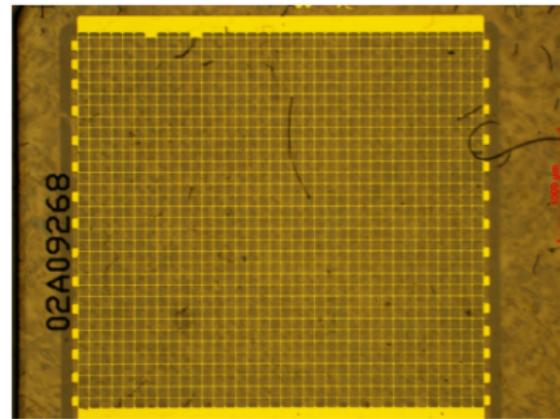


Full 3D Detector (May/Sep 2016)

- 3 dramatic improvements compared to 3D Multi:
 - ▶ an order of magnitude more cells: from 99 to 1188
 - ▶ smaller cell size: $100\text{ }\mu\text{m} \times 100\text{ }\mu\text{m}$
 - ▶ higher column efficiency: from 92 % to 99 %



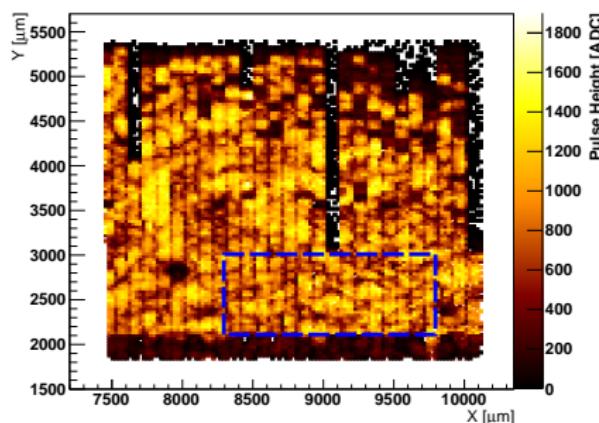
(a) readout side



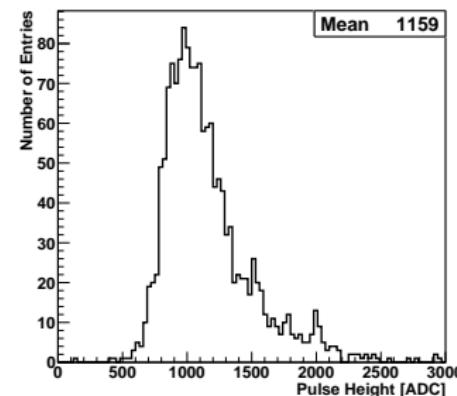
(b) bias side

Full 3D Preliminary Results

- analysis in progress
- device seems to perform well
- see charge in entire detector
- largest charge collection in pCVD yet
 - >85 % over contiguous region



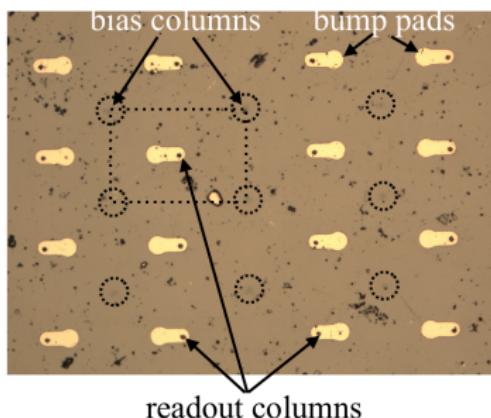
(a) charge map



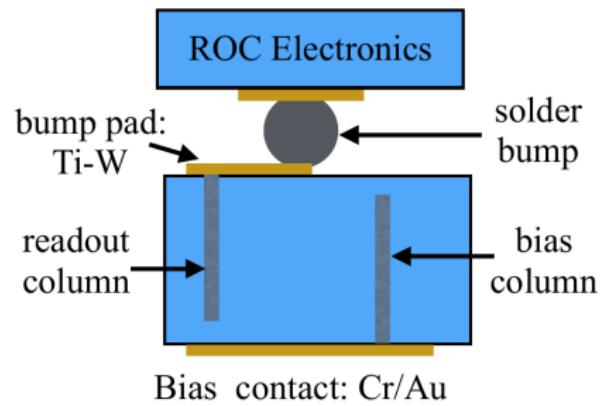
(b) charge distribution

3D Pixel Detector - Fabrication

- cleaning and photo-lithography
- connect to bias and readout with surface metallisation
- bump and wire bonding

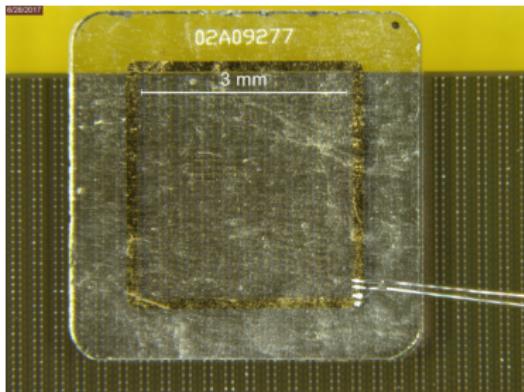


(a) pixel readout metalisation

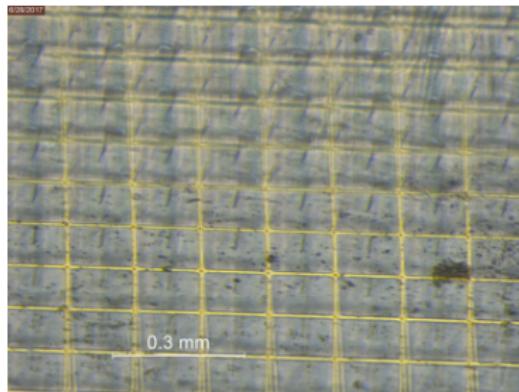


(b) final scheme

3D Pixel Detector



(a) detector bonded on CMS-Pixel-Chip



(b) bias grid and R/O columns

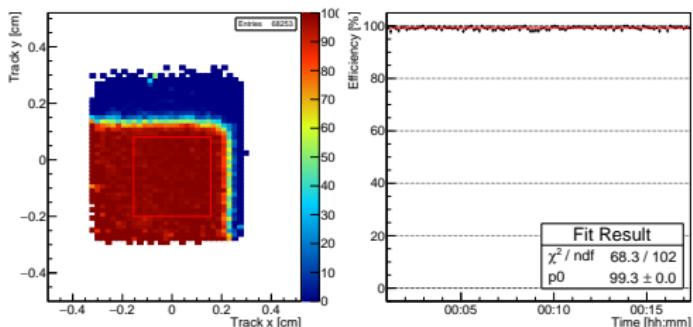
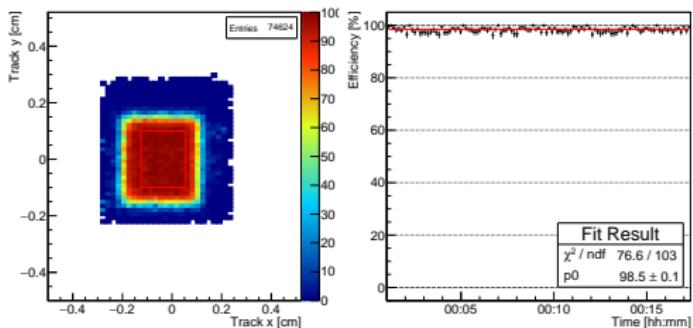
- successful production of a working 3D pixel detector

3D Pixel Detector - Preliminary Results

→ 3D Diamond Pixel
→ 98.5 % Efficiency

- efficiencies flat in time
 - pixel threshold: 1500 e
 - lower efficiency in diamond
probably due to low field regions

Planar Silicon Pixel (Ref)
→ 99.3 % Efficiency

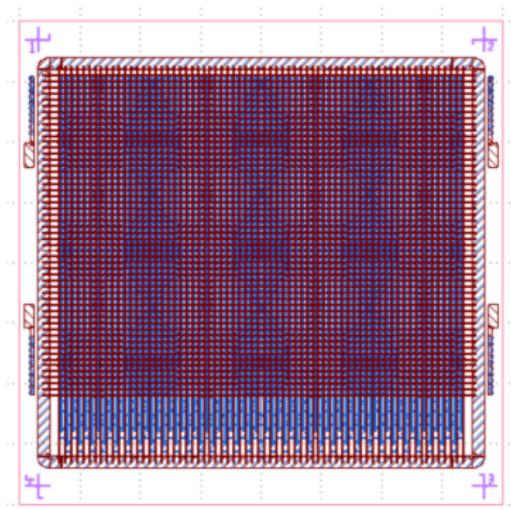


(a) efficiency maps

(b) hit efficiencies

3D Pixel Detector - New Design

- currently producing 3500 cell pixel prototype with $50\text{ }\mu\text{m}$ pixel pitch
 - two independent drillings (Oxford - complete, Manchester - in progress)
 - bump bonding at Princeton (CMS) and IFAE (ATLAS)
 - CMS device probably ready for August beam tests



Section 7

Conclusion

Conclusion

- impact of diamonds in LHC is increasing
 - one of the first pixel projects started taking data:
 - ▶ ATLAS DBM re-commissioned for 13 TeV collisions
 - quantification and understanding of the rate effects in diamond
 - ▶ pCVD shows no rate effect up to $10\text{ MHz}/\text{cm}^2$
 - ▶ shown for fluence up to $5 \times 10^{14} \text{ n}/\text{cm}^2$
 - great progress in 3D detector prototypes
 - ▶ 3D works in pCVD diamond; scale up and smaller cells also worked
 - production and successful test of 3D diamond pixel devices
 - ▶ efficiency looks good; pulse height in progress